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<h1>TRANSMITTAL FORM</h1> <p>(to be used for all correspondence after initial filing)</p>	Applicant Number	09/625,336
	Filing Date	Jul 25, 2000
	First Named Inventor	Kori, Moris
	Group Art Unit	1763
	Examiner Name	Unassigned
Total Number of Pages in This Submission		Attorney Docket Number 4714d1/AMI-07

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ENCLOSURES (check all that apply)		
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Remarks		

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT	
Firm or Individual name	Law Office of Kenneth C. Brooks
Signature	
Date	November 8, 2001

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Kori et al.

Serial No: 09/625,336

Filed: July 25, 2000

For: METHOD AND SYSTEM FOR CONTROLLING THE PRESENCE OF
FLUORINE IN REFRACTORY METAL LAYERS

PATENT APPLICATION

Group Art Unit: 1763

Examiner: unassigned

Supplemental Information Disclosure Statement

Hon. Commissioner
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Sir:

The following information is submitted in compliance with Applicants' duty of disclosure under 37 C.F.R. § 1.56. A copy of each reference recited below accompanies this document. Also enclosed are two (2) sheets of PTO form 1449 listing these references.

PATENT DOCUMENT

Patent Number

5,580,380

Inventor

Liu et al.

Grant Date

03-Dec-96

PCT DOCUMENT

Publication No.

WO 98/51838

Inventor

Rajagopalan et al.

Publication Date

19-Nov-98



NON-PATENT DOCUMENT

Kitagawa et al. Hydrogen-Mediated Low-Temperature Epitaxy of Si in Plasma-Enhanced Chemical Vapor Deposition, Applied Surface Science, pp. 30-4 (2000).

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Respectfully submitted,

Kenneth C. Brooks
Reg. No. 38,393